

Ion beam preparation of Au nanoparticles in crystalline GaN and ZnO semiconductors

A. Jagerová¹, R. Mikšová², P. Malinský^{1,2}, Z. Sofer³, M. Vronka⁴, A. Galeckas⁵, A. Azarov⁵, A. Macková^{1,2}

¹*Department of Physics, Faculty of Science, Jan Evangelista Purkyně University, Pasteurova 3632/15, Ústí nad Labem 400 96, Czech Republic*

²*Nuclear Physics Institute, Czech Academy of Sciences, Řež 250 68, Czech Republic*

³*Department of Inorganic Chemistry, University of Chemistry and Technology Prague, Technická 5, Prague 6 166 28, Czech Republic*

⁴*FZU - Institute of Physics of the Czech Academy of Sciences, Na Slovance 1999/2, Prague 18200, Czech Republic*

⁵*Department of Physics, Centre for Materials Science and Nanotechnology, University of Oslo, P.O. Box 1048, Blindern, Oslo N-0316, Norway*

Wurtzite crystalline semiconductors, such as gallium nitride (GaN) and zinc oxide (ZnO), are widely used in electronics, energy storage devices, sensors, and as photocatalysts due to their attractive optoelectronic properties^{1,2}. However, their wide bandgaps limit their functionality mainly to the UV region. Modification with metallic gold (Au) nanoparticles can enhance charge-carrier mobility and device performance³. Moreover, Au nanoparticles exhibit visible light absorption due to surface plasmon resonance (SPR), thereby extending the application range of these semiconductors⁴. Ion implantation is a promising direct method to synthesize metal nanoparticles within solids, offering high purity and stability⁵. However, this process may introduce structural damage and impact material properties, especially in crystals, necessitating a detailed investigation. In this work, Au nanoparticles were formed via 1.85 MeV and 1 MeV Au ion implantation in crystalline GaN and ZnO, respectively. Implantation in ZnO caused less lattice damage than in GaN, and the Au ions exhibited a Gaussian depth distribution as characterized by Rutherford Backscattering Spectroscopy in channeling mode (RBS-C). GaN showed a more complex damage profile, resulting in a multimodal Au depth distribution, also confirmed by RBS-C. Transmission electron microscopy revealed distinct stages of Au nanoparticle formation in GaN. These stages, along with crystal quality, significantly influenced the optical response, as characterized by absorption/reflection measurements and photoluminescence. In particular, implanted GaN exhibited new blue (2.8 eV) and red (2 eV) emission bands, attributed to the combined effects of SPR and implantation-induced defects.

1) J. L. Weyher et. al, *Applied Surface Science*, 2019, 466.

<https://doi.org/10.1016/j.apsusc.2018.10.076>

2) N. Morales-Flores et. al, *Applied Catalysis A: General*, 2011, 394.

<https://doi.org/10.1016/j.apcata.2011.01.011>

- 3) H. Zheng et. al, *Physica Status Solidi (a)*, 2023, 220.
<https://doi.org/10.1002/pssa.202300037>
- 4) S. Lu et. al, *ACS Appl. Mater. Interfaces*, 2014, 6. <https://doi.org/10.1021/am503442c>
- 5) M. C. Salvadori et. al, *Applied Surface Science*, 2014, 310.
<https://doi.org/10.1016/j.apsusc.2014.03.145>